



Attorney Docket No. 1572.1242

cofc

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Je-hyoung RYU et al.

Application No.: 10/823,546

ATTENTION

Confirmation No.: 4401

CERTIFICATE OF CORRECTION

Filed: April 14, 2004

BRANCH

U.S. Patent No.: 7,176,704

Issued: February 13, 2007

For: INSPECTING APPARATUS FOR SEMICONDUCTOR DEVICE

REQUEST FOR CERTIFICATE OF CORRECTION

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

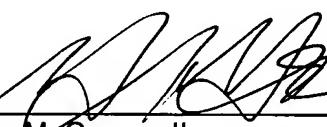
Patentee(s) respectfully request(s) that a Certificate of Correction be issued in the subject patent, pursuant to 35 U.S.C. §254 and 37 C.F.R. §1.322, to correct the mistake(s) shown on the attached Form PTO-1050.

Since the mistakes are Patent Office mistakes, it is believed that no fee is required.

Respectfully submitted,

STAAS & HALSEY LLP

Date: April 4, 2007

By: 

Gene M. Garner, II
Registration No. 34,172

1201 New York Ave, N.W., 7th Floor
Washington, D.C. 20005
Telephone: (202) 434-1500
Facsimile: (202) 434-1501

Certificate

APR 06 2007

of Correction

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UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF CORRECTION

PATENT NO : 7,176,704

DATED : February 13, 2007

INVENTOR(S) : Je-hyoung RYU et al.

Column 10, Line 13, change "peat." to --seat--.

MAILING ADDRESS OF SENDER:

STAAS & HALSEY LLP
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7th Floor
Washington, DC 20005PATENT NO. 7,176,704No. of add'l copies
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